

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/475,545
Priority Filing Date December 30, 1999
Inventor Michael T. Andreas
Assignee Micron Technology, Inc.
Priority Group Art Unit 3723
Priority Examiner G. Nguyen
Attorney's Docket No. MI22-1881
Title: Chemical-Mechanical Polishing Methods


INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/475,545, filed December 30, 1999. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Respectfully submitted,

Dated: 20 Nov 2001

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